

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/011,022	<b>Applicant(s)/Patent under Reexamination</b> VANDERSLUIS, KIRSTAN ANDERSON
	<b>Examiner</b> David Y. Jung	<b>Art Unit</b> 2134

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner